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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: Walter SCHWARZENBACH et al. Confirmation No. 9739  
Application No.: 10/733,729 Group Art Unit: 2812  
Filing Date: December 12, 2003 Examiner: D. Nhu  
For: METHOD OF MAKING CAVITIES IN A Atty. Docket No.: 4717-9200  
SEMICONDUCTOR WAFER

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This communication responds to the Office Action dated April 28, 2005, concerning the above-identified application.

**Amendments to the Specification** appear on page 2.

**Amendments to the Drawings** appear on page 3.

**Amendments to the claims** begin on page 4.

**Remarks** begin on page 8 of this paper.

No fee is believed due with this Amendment. Please charge any fee deemed necessary to Winston & Strawn LLP Deposit Account No. 50-1814.